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AMENDMENT TRANSMITTAL LETTER

Docket No.
291958170US2Application No.
09/885,451-Conf. #3390Filing Date
June 20, 2001Examiner
W. T. LeaderArt Unit
1742

Applicant(s): Ritzdorf et al.


Invention: METHOD AND APPARATUS FOR LOW TEMPERATURE ANNEALING OF
METALLIZATION MICRO-STRUCTURES IN THE PRODUCTION OF A
MICROELECTRONIC DEVICE

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	25	- 39 =	0	x	
Independent Claims	5	- 7 =	0	x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify): Extension for response within first month					120.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					120.00

☒ Large Entity☐ Small Entity☐ No additional fee is required for this amendment.☐ Please charge Deposit Account No. 50-0665 in the amount of \$ _____
A duplicate copy of this sheet is enclosed.☒ A check in the amount of \$ 120.00 to cover the filing fee is enclosed.☐ Payment by credit card. Form PTO-2038 is attached.☒ The Director is hereby authorized to charge and credit Deposit Account No. 50-0665
as described below. A duplicate copy of this sheet is enclosed.☒ Credit any overpayment.☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.
Paul T. Parker
Attorney/Agent Reg. No.: 38,264

Dated: May 12, 2006

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(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Ritzdorf et al.

Application No.: 09/885,451

Confirmation No.: 3390

Filed: June 20, 2001

Art Unit: 1742

For: METHOD AND APPARATUS FOR LOW
TEMPERATURE ANNEALING OF
METALLIZATION MICRO-STRUCTURES
IN THE PRODUCTION OF A
MICROELECTRONIC DEVICE

Examiner: W. T. Leader

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated 12 January 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.